



LEIR

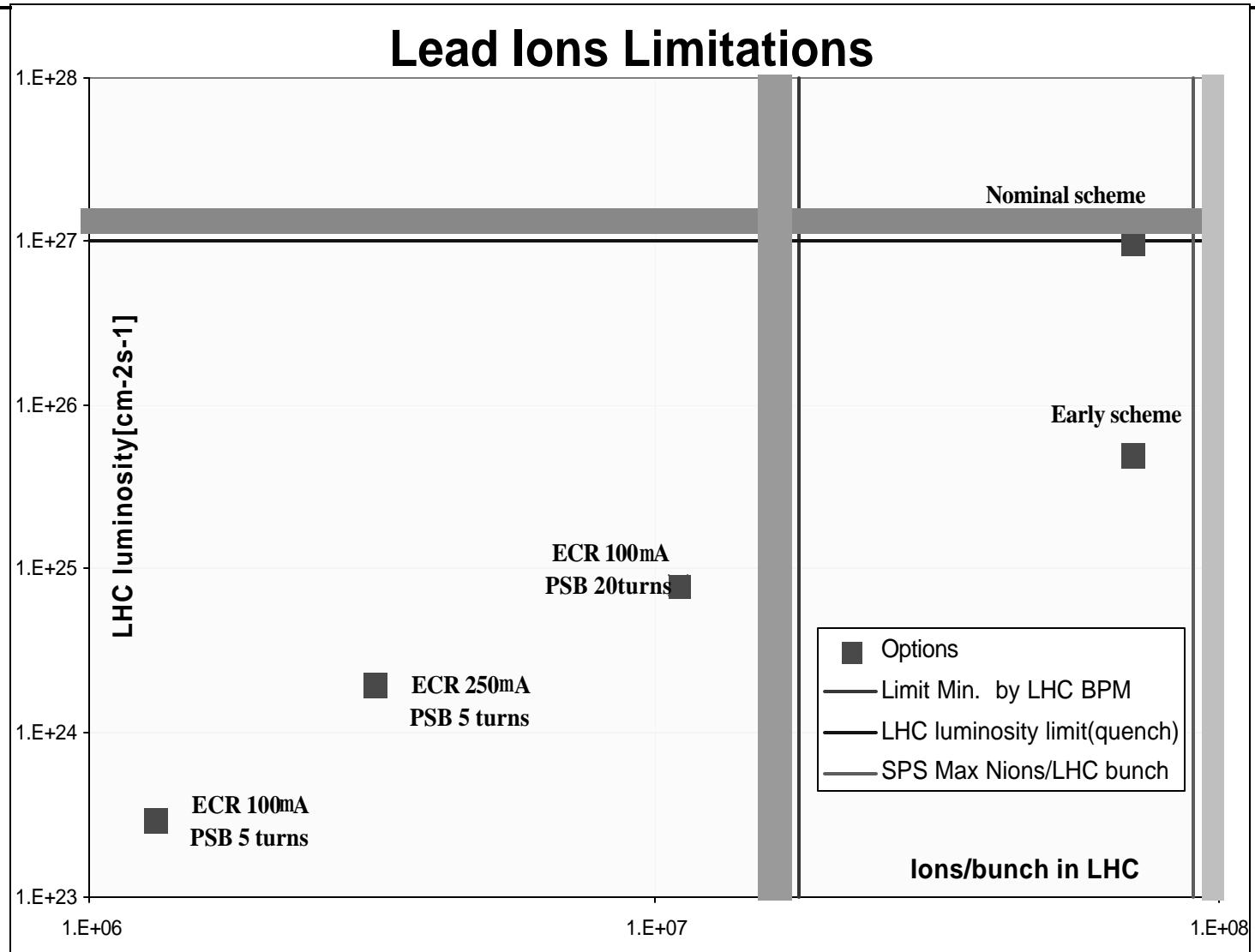


LHC NEEDS

- LEAD ions
- At 2.7 TeV/n , $L=10^{27} \text{ cm}^{-2}\text{s}^{-1}$ limited by central detector and by magnet quenches (note: $\sigma_{\text{tot}}=437$ barns-e.m.d.,ecpp hadronic-, $\sigma_{\text{hadronic}}=8$ barns !!!)
- Luminosity is obtained by about 592 bunches, $7 \cdot 10^7$ ions/bunch, $\varepsilon_n=1.5\mu\text{m}$ and $\beta^*=0.5\text{m}$
- First run, early scheme, $L=5 \cdot 10^{25} \text{ cm}^{-2}\text{s}^{-1}$ (60 bunches, $7 \cdot 10^7$ ions/bunch, $\beta^*=1$)
- ALICE, ATLAS, CMS
- <http://documents.cern.ch/AGE/current/fullAgenda.php?ida=a021004>

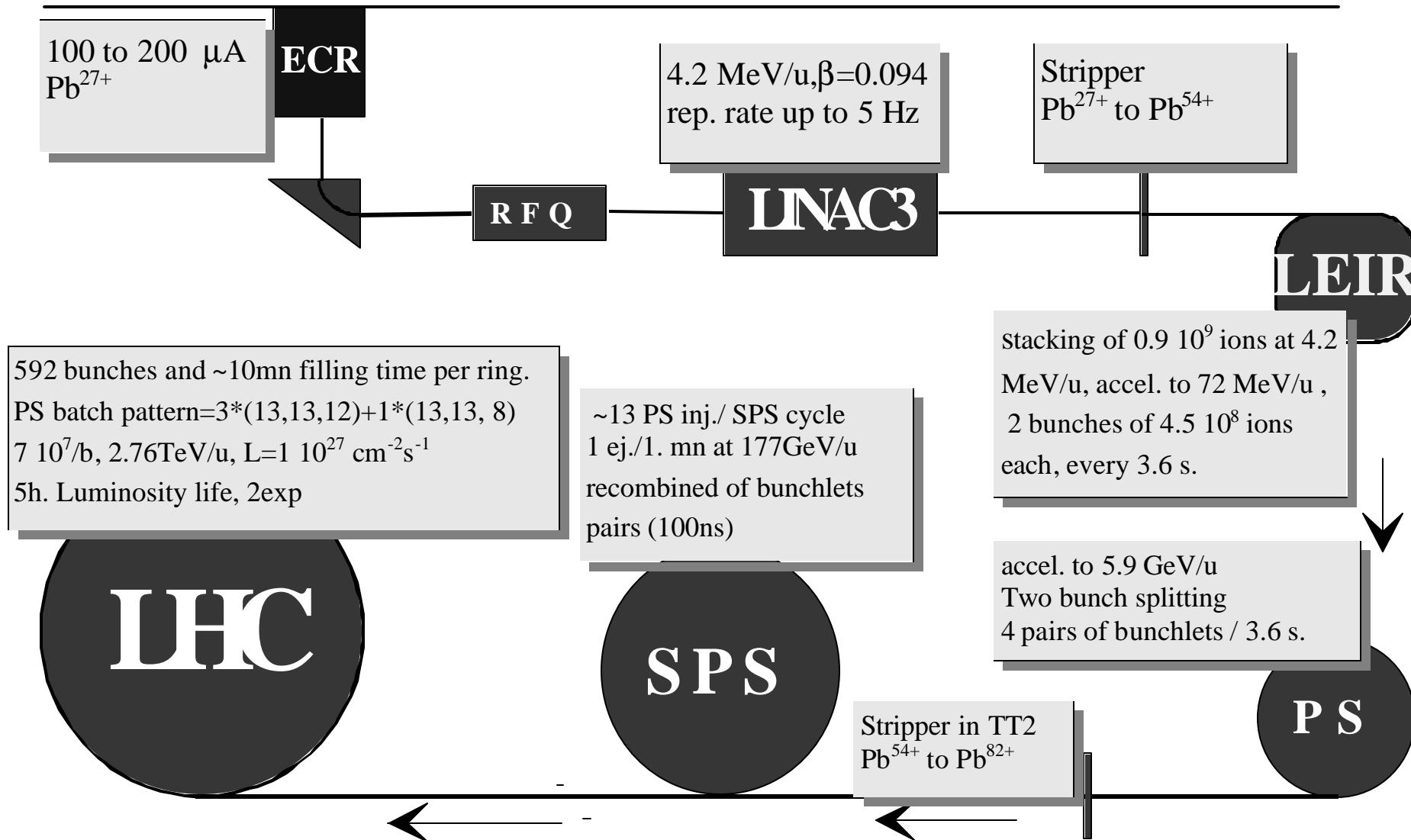


LIMITATIONS



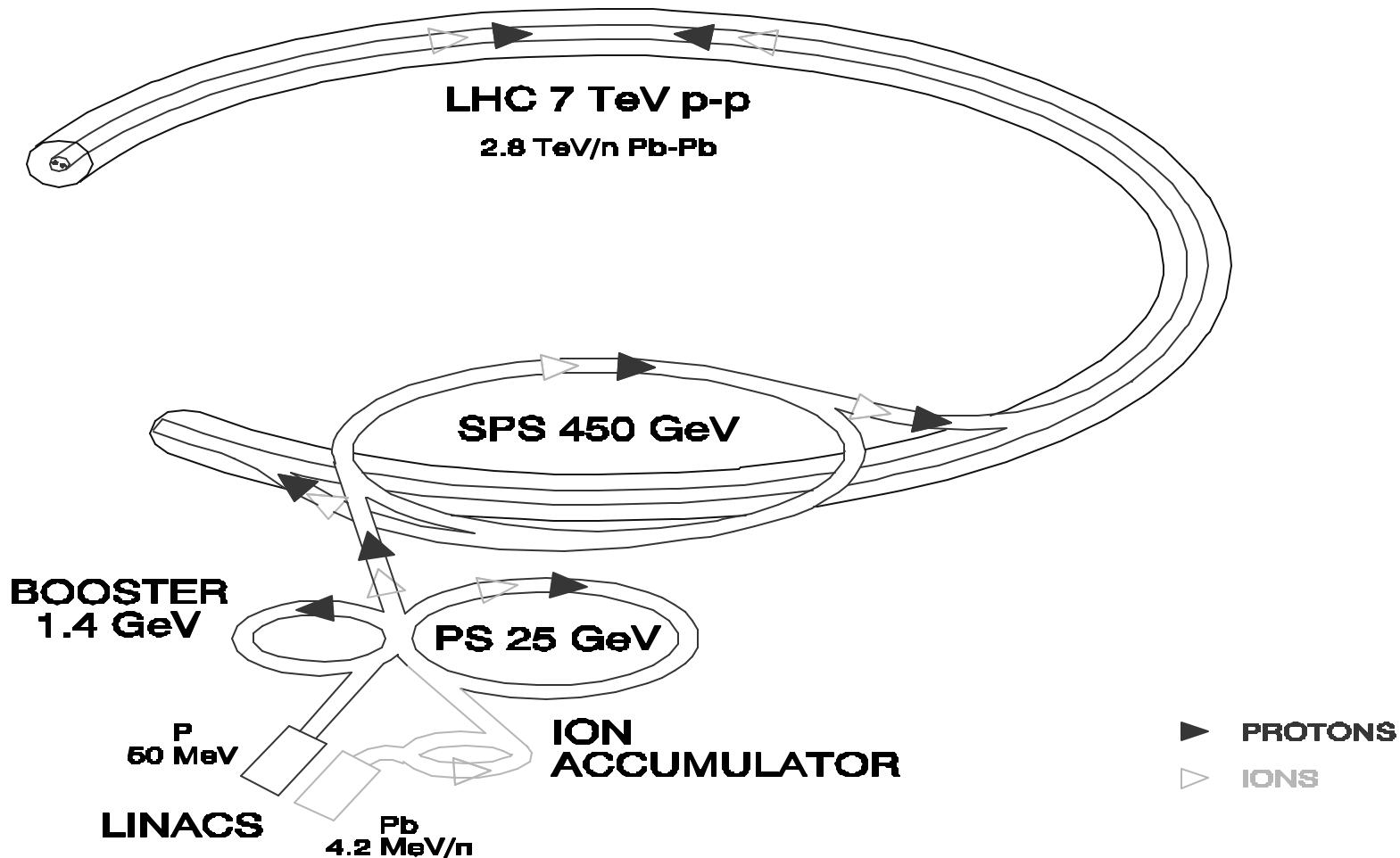


GENERAL SCHEME





Overall injection chain



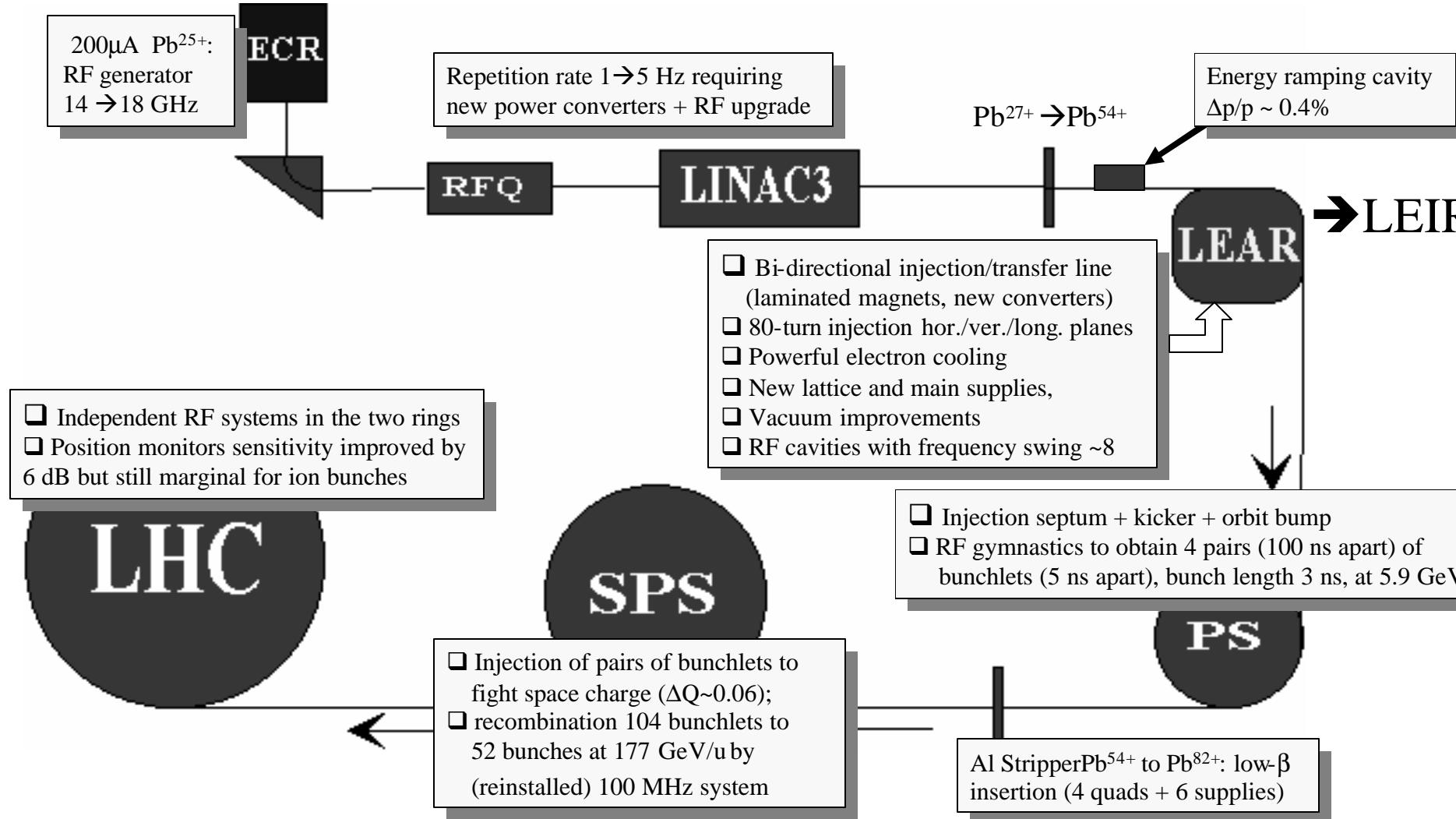


BEAM PARAMETERS

- Overall efficiency 30%
- LHC $\varepsilon_t = 1.5 \mu\text{m}$, $\varepsilon_l = 1.0 \text{ eVs/n/bunch}$
- SPS extraction $\varepsilon_t = 1.2 \mu\text{m}$, $\varepsilon_l = 0.28 \text{ eVs/n/bunch}$
- SPS injection after stripping (4 pairs of bunchlets) $\varepsilon_t = 1.0 \mu\text{m}$,
 $\varepsilon_l = 0.025 \text{ eVs/n/bunchlet}$
- PS injection(2 bunches) $\varepsilon_t = 0.7 \mu\text{m}$, $\varepsilon_l = 0.05 \text{ eVs/n/bunch}$

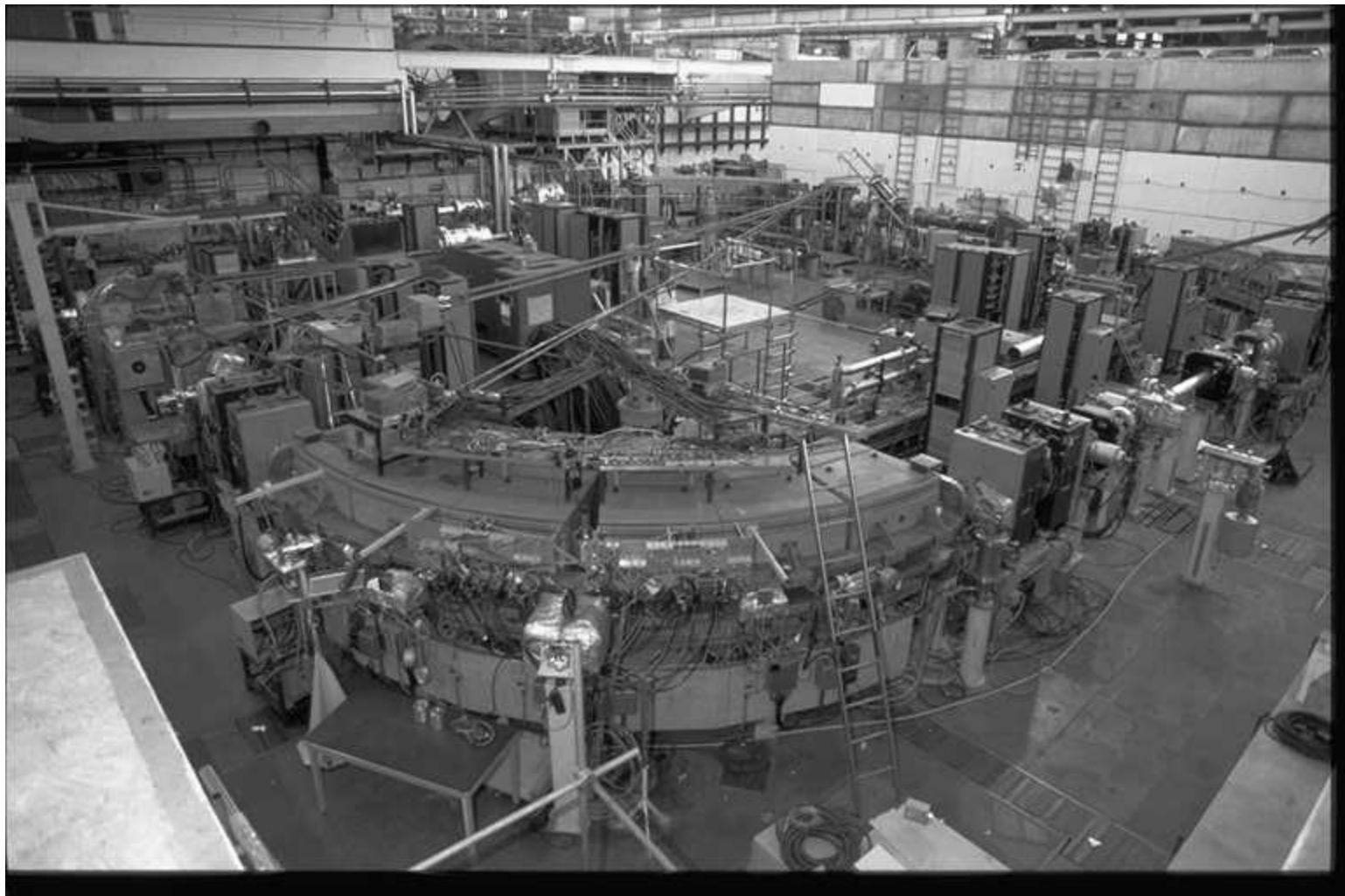


Hardware Upgrades



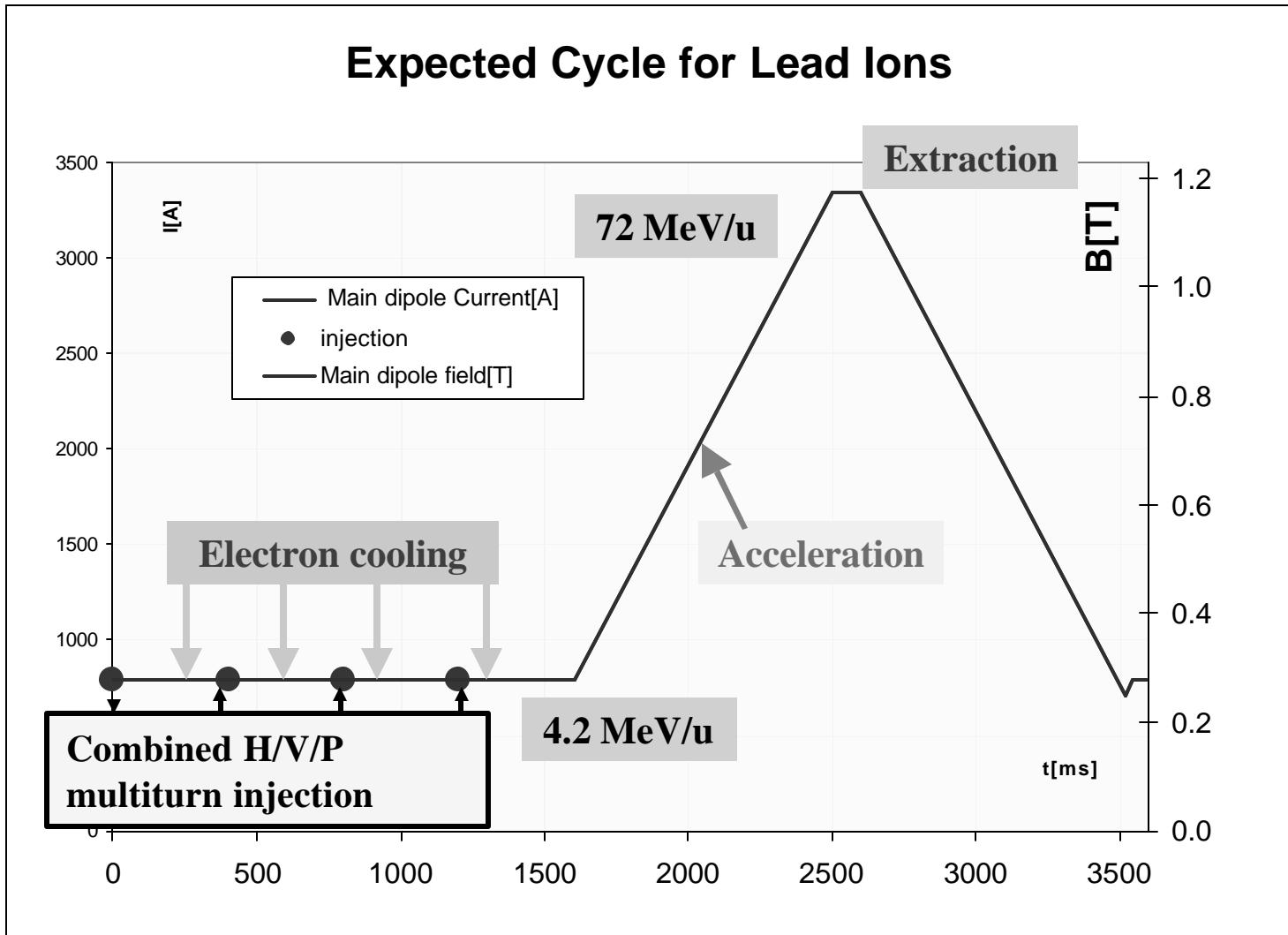


LEAR in 1997

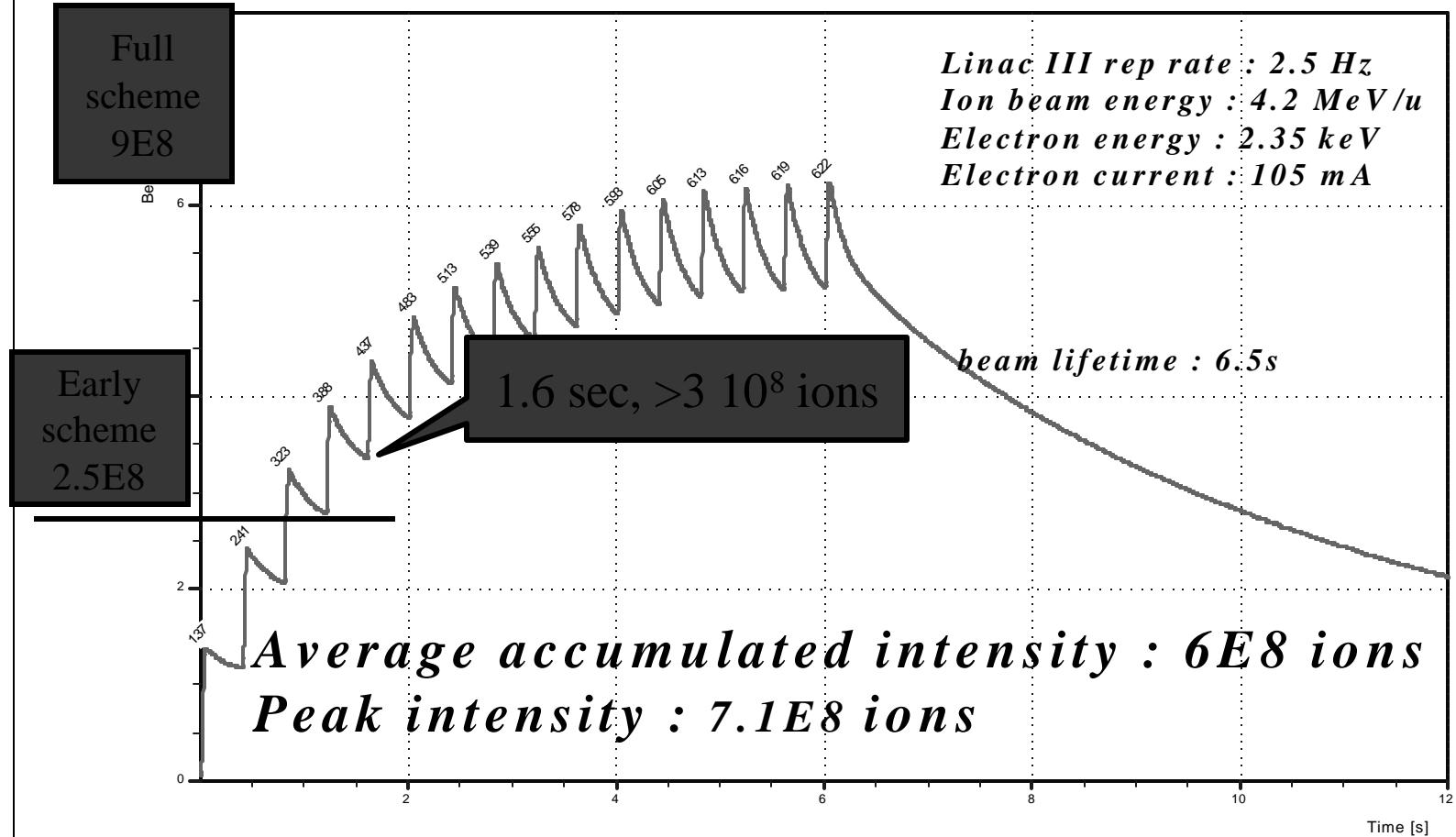




LEAD IONS in LEIR



1997 tests



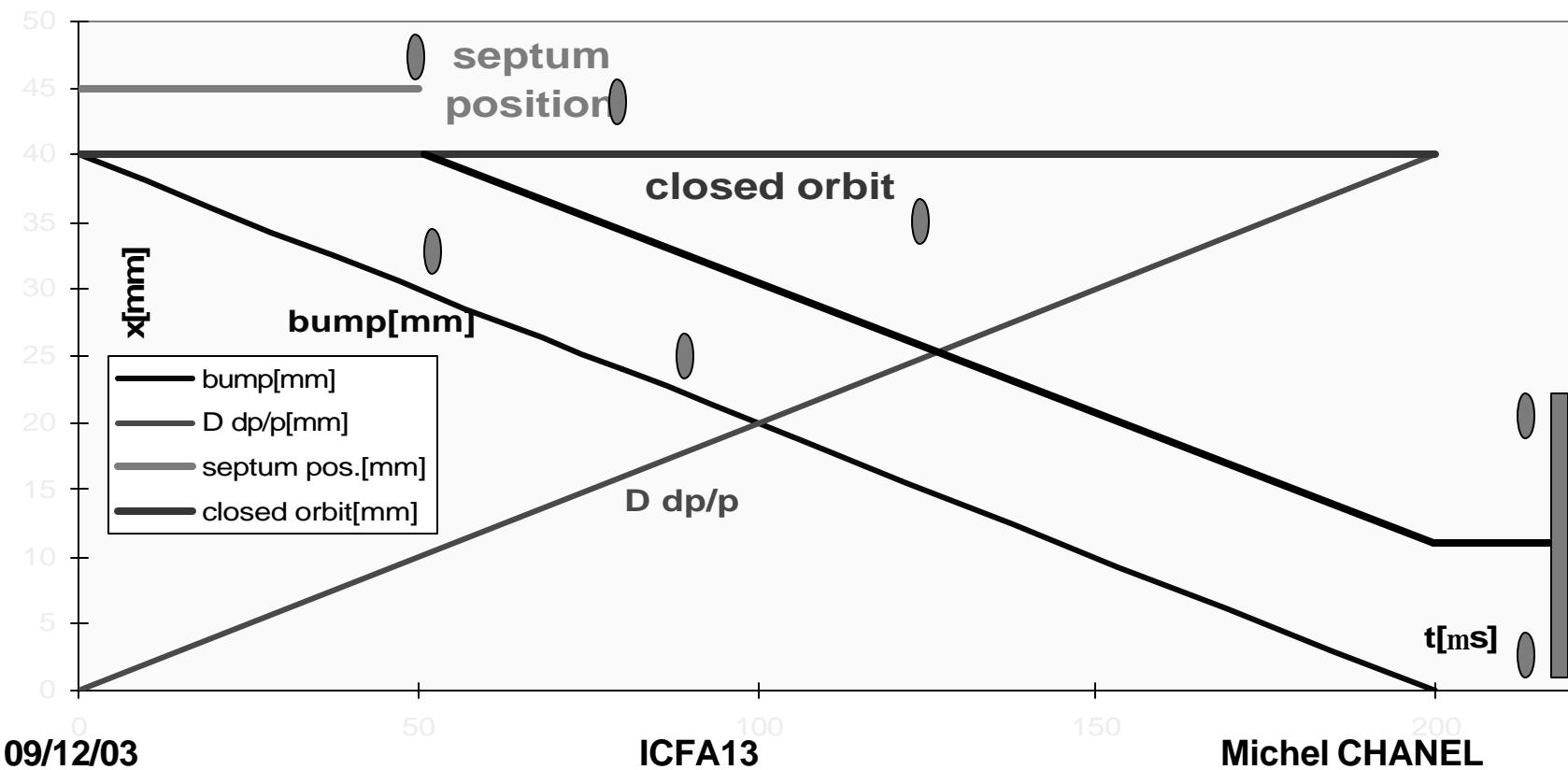


INJECTION



- Combined injection gives decreases ϵ_t (better cooling time) compared to normal multiturn but increases mom. spread (good long. cool.).
- Combined injection implies large D and $D/h \sim 5m^{1/2}$ ($D=10$, $\beta_h=3$).

Injection into LEIR(dp/p from 0 to 0.4%)



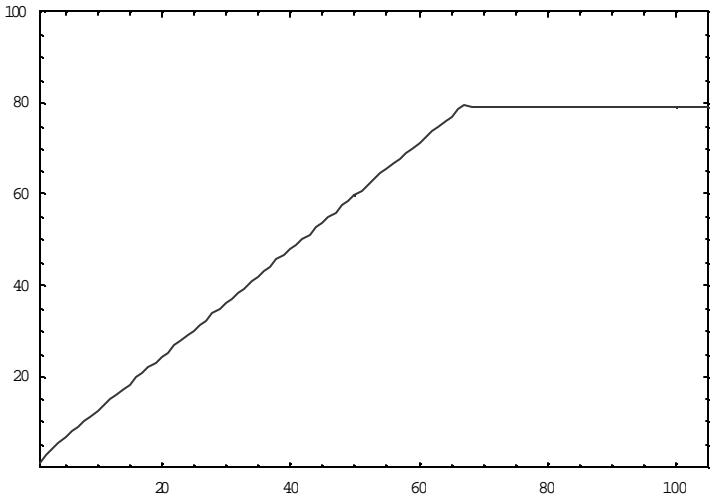


ANIMATED INJECTION



- Bump 60mm-0.6mm/turn, 70turns injected (efficiency. 80%), 105 turns shown, $\delta p/p$ from -0.1% to 0.3%, stack at -0.2%





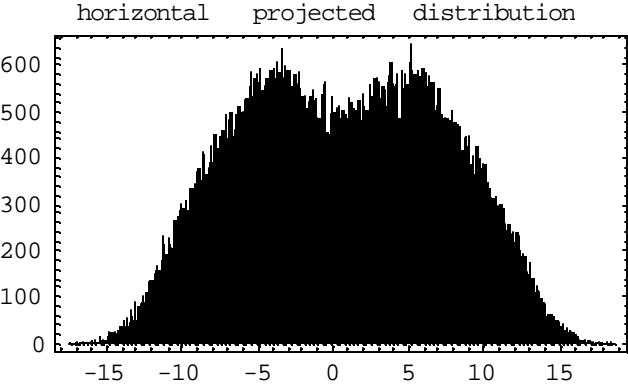
Out[252]= Graphics -

The momentum spread at the end of stacking is $4.22 \cdot 10^{-3}$

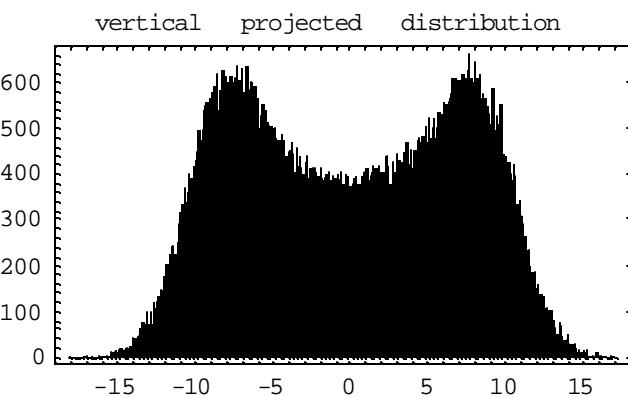
After 68 turns injected there are 54 efficient turns injected i.e. an efficiency of 78.7761%

injection

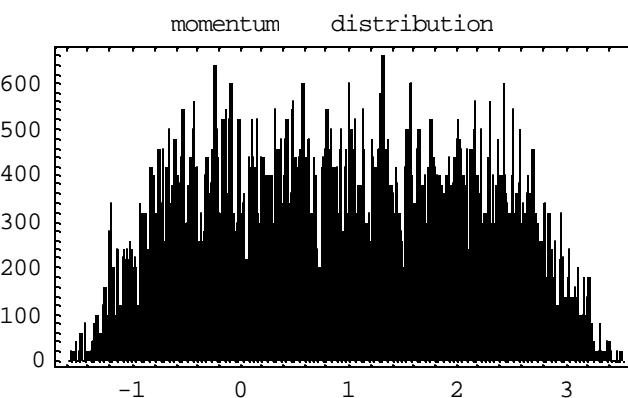
•x and y and momentum
projected distributions of the
injected beam



emittanceh= 71.8913 at 95%



emittancev= 30.6782 at 95%



dp/p= 4.12586E-3 at 95%

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Cooling and Stacking



- Electron cooling theory gives:

$$\tau \propto \frac{\theta^3}{\eta \cdot I_e} \frac{A}{Q^2}$$

- where θ is the relative difference in angle between the ions and electrons [$\theta_i = \sqrt{(\epsilon/\beta)}$]
- the parameter $\eta_{\text{cool}} = L_{\text{cooler}}/L_{\text{machine}}$
- and I_e is the electron current.
- A and Q: atom mass and charge state

- Large β desirable but ion beam size should remain smaller than e-beam size and mind the effect of the e-beam space charge.... optimum around $\beta=5m$

- With $D=0$, stack and injected beam are in the centre of the e-beam, but this is not the best value for cooling.

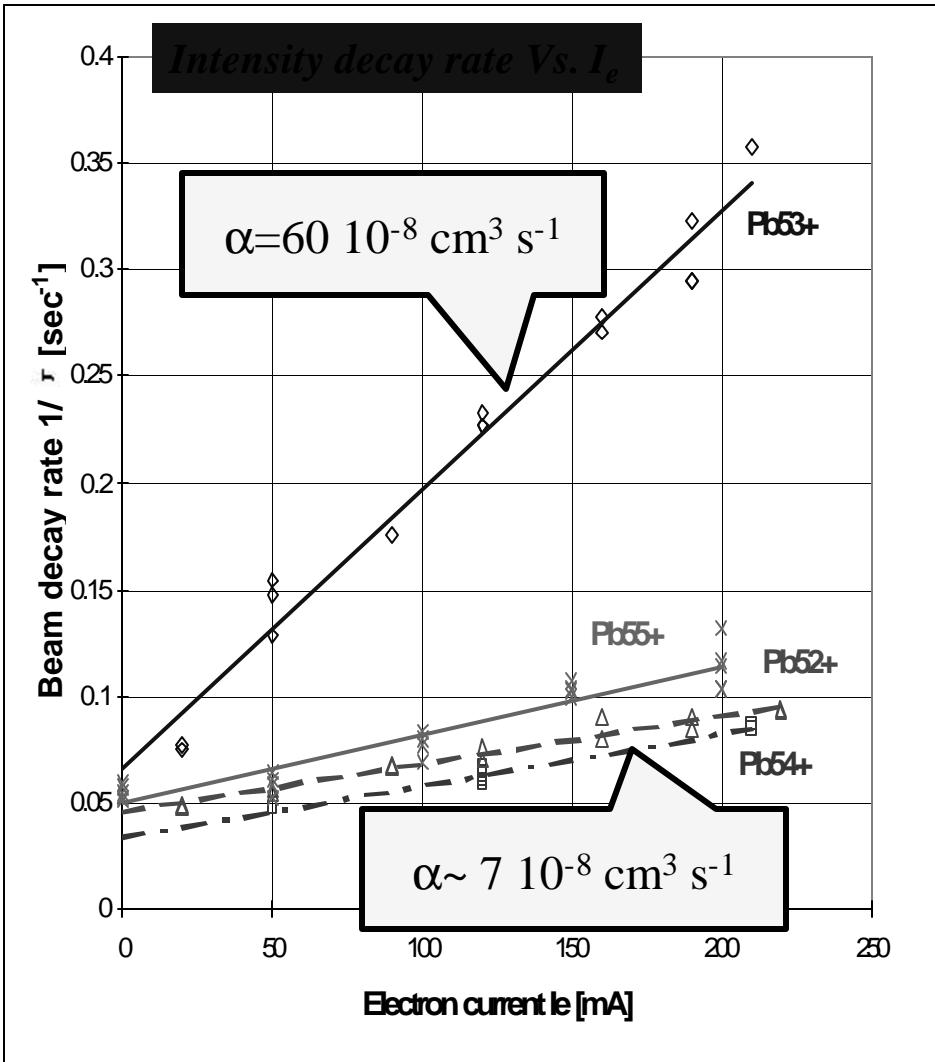


Ion Beam Lifetime Vs. I_e

- Ion beam lifetime measured as a function of electron current.
 - $1/t = 1/t_{vac} + 1/t_{rec}$
- Zero crossing gives the lifetime due to charge exchange with the residual gas.
- Slope of the curves gives the recombination rate coefficient

$$a = \frac{1}{t_{rec}} \times \frac{1}{2.25 \times 10^6} \times \frac{1}{I_e}$$

- Lead53+ dielectronic recomb.
- Lead 54+: Life time ~ 15 s with $2.5 \times 10^7 \text{ e}^-/\text{cm}^3$





Cooling and Stacking

- Loss rate(LR) due to recombination between electrons and well cooled ions is:

$$\frac{1}{t_{\text{rec}}} = n_{\text{eff}} a \quad n_{\text{eff}} = \frac{I_e}{epa^2 bc} h_c$$

$$a [10^{-13} \text{ cm}^3 \text{s}^{-1}] = \frac{3.02 Z_{\text{eff}}^2}{\sqrt{kT}} \left(\ln \left(\frac{11.32 Z_{\text{eff}}}{\sqrt{kT}} \right) + 0.14 \left(\frac{kT}{Z_{\text{eff}}^2} \right)^{\frac{1}{3}} \right)$$

- To limit LR and also have a good cooling:
 - Low electron density on stack (e-beam center)
 - High electron density elsewhere for large amplitude ions



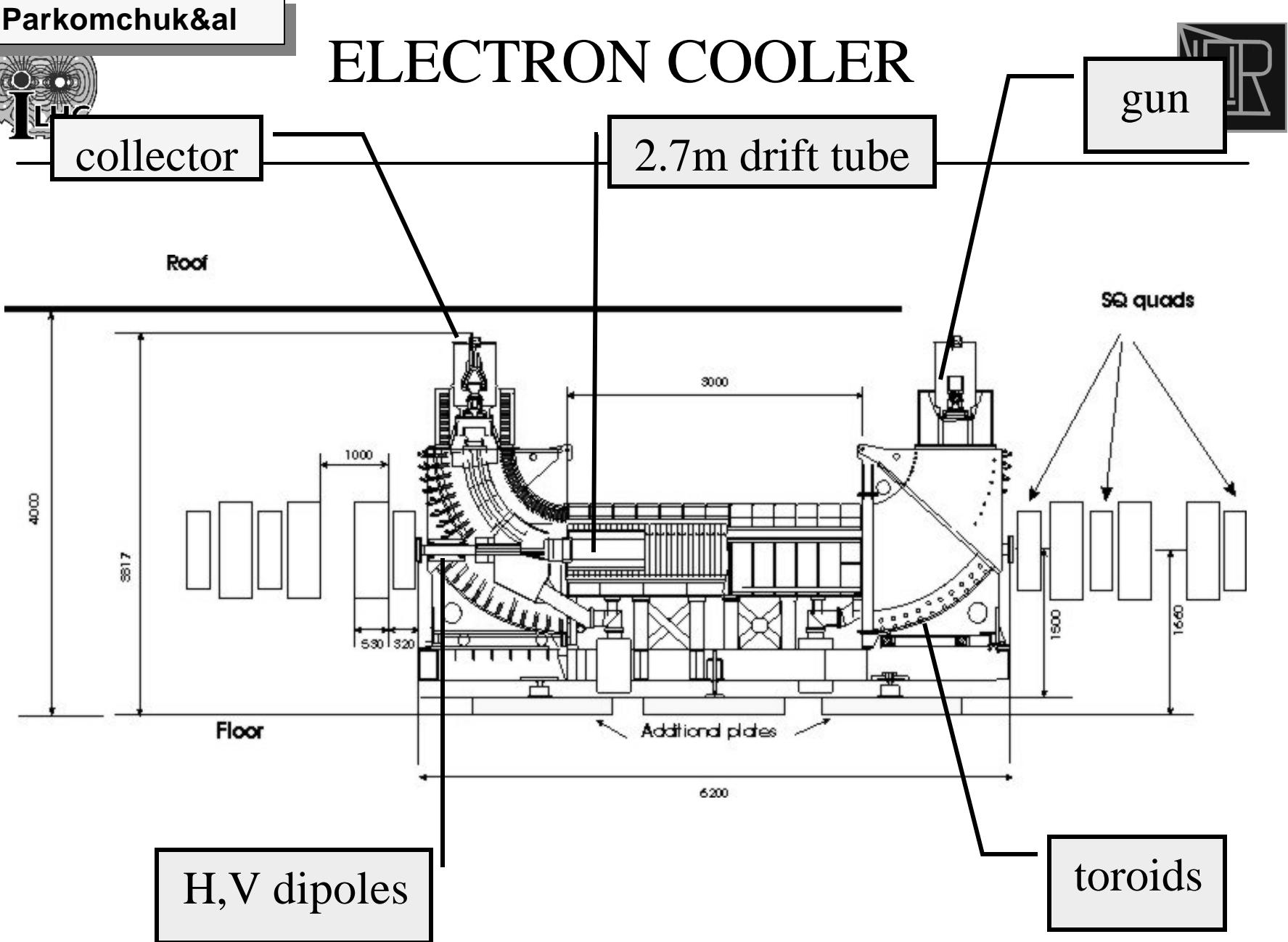
Magnetic characteristics

			Comments
B Gun max	up to 2.4	kG	still normal conducting
B Toroid and Drift Max	up to 1	kG	
B Toroid and Drift Nominal	0.75	kG	insure magnetisation

ELECTRON BEAM CHARACTERISTICS

			Comments
CATHODE VOLTAGE	2.4	kV	up to 40kVpossible
Cathode diameter(convex)	29	mm	
GUN PERVEANCE	3 to 6	μ P	$I_e = P^* V_0^3 / 2$
Electron current at $b=0.0945$	0.6	A	
Electron current max	3	A	
Expansion Max	6		
E-Beam diameter max	70	mm	
Cooling length wanted	2.7	m	

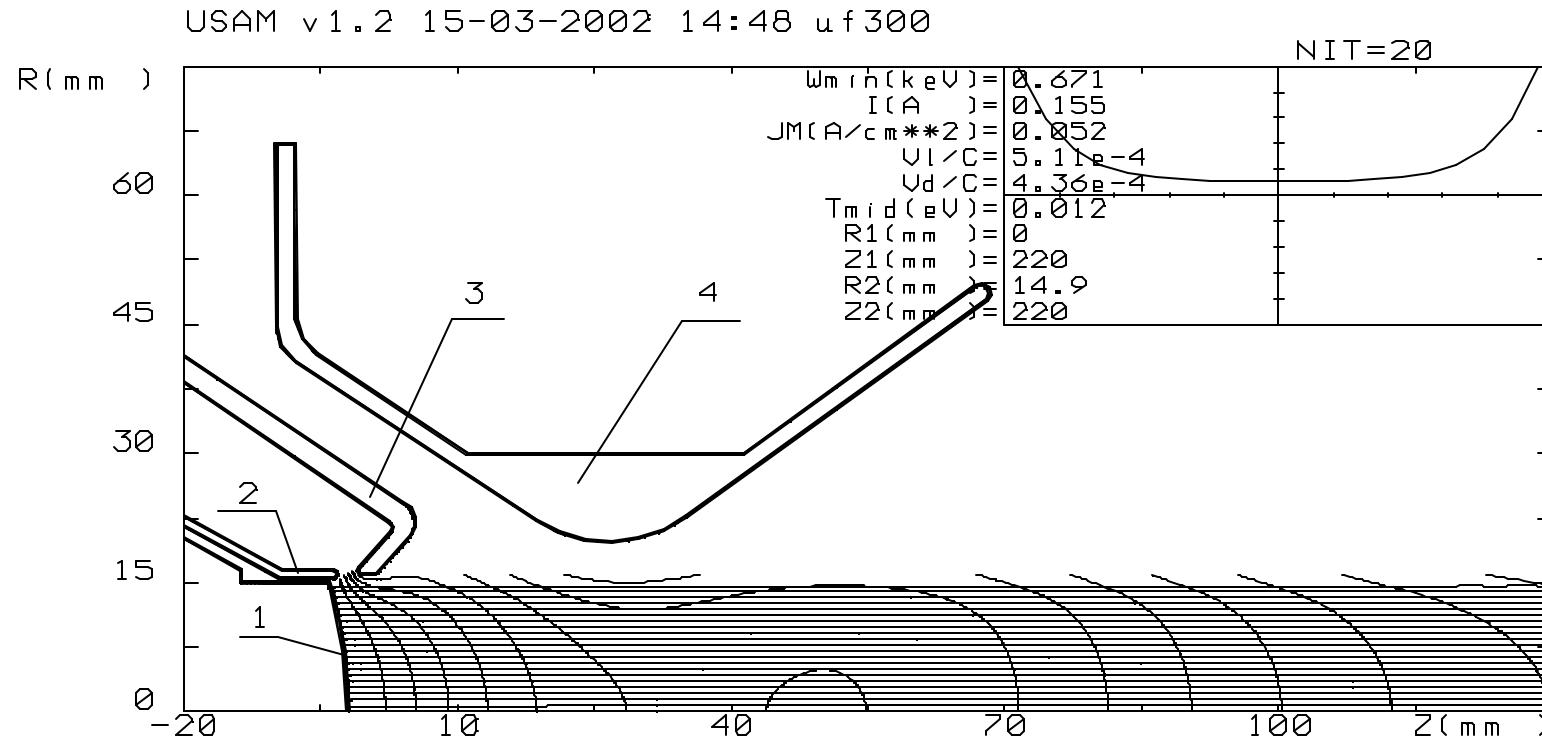
ELECTRON COOLER





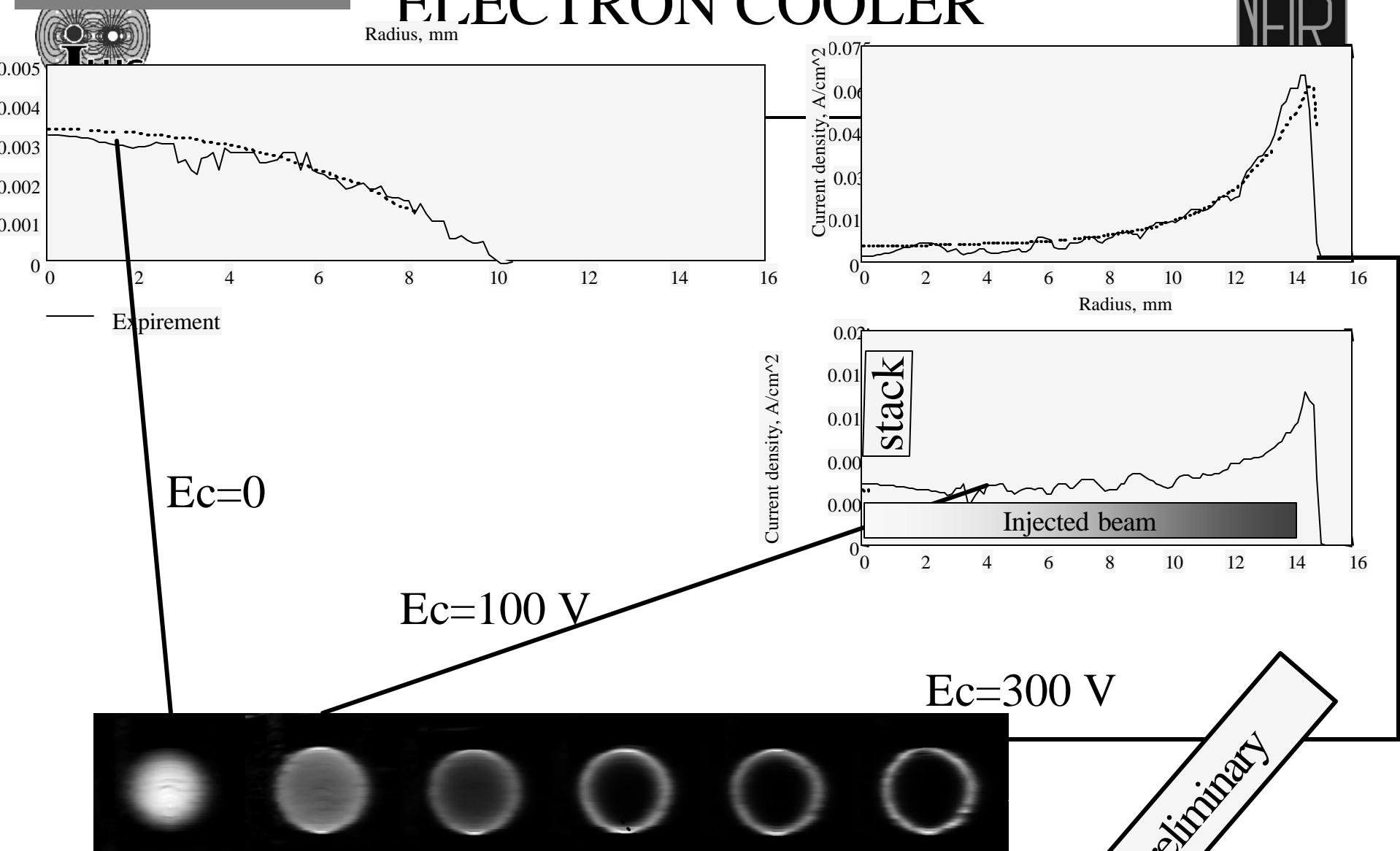
ELECTRON COOLER

preliminary



Geometry of electron gun with variable beam profile; equipotentials, trajectories; beam profile on the exit from the gun. (1)cathode, (2) forming electrode, (3)control electrode, (4) grid

ELECTRON COOLER



<http://accelconf.web.cern.ch/AccelConf/e02/PAPERS/WEPR049.pdf>

Radius, mm

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..... Calculation

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LEIR LATTICE

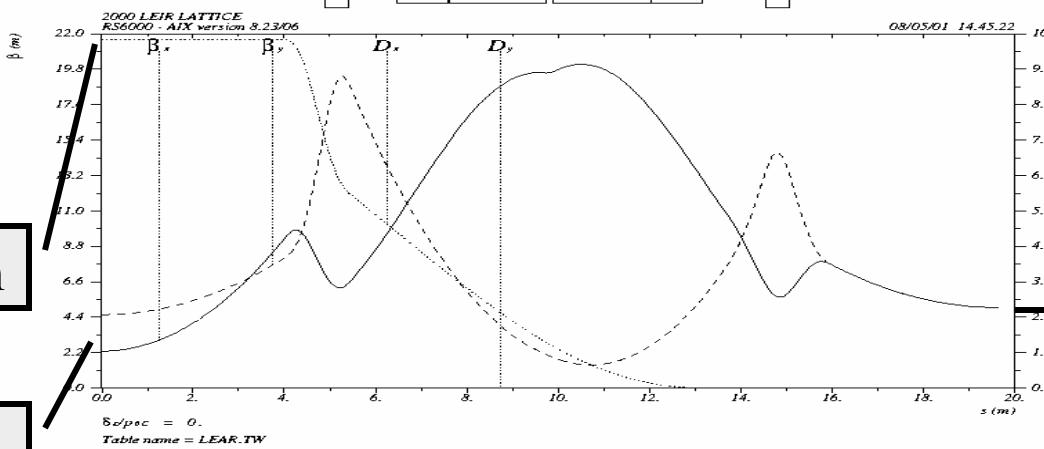


doublet

90 deg.
bending

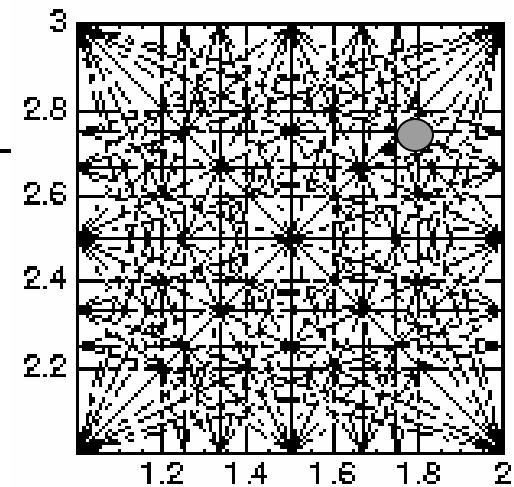
triplet

Injection ...



D=10m

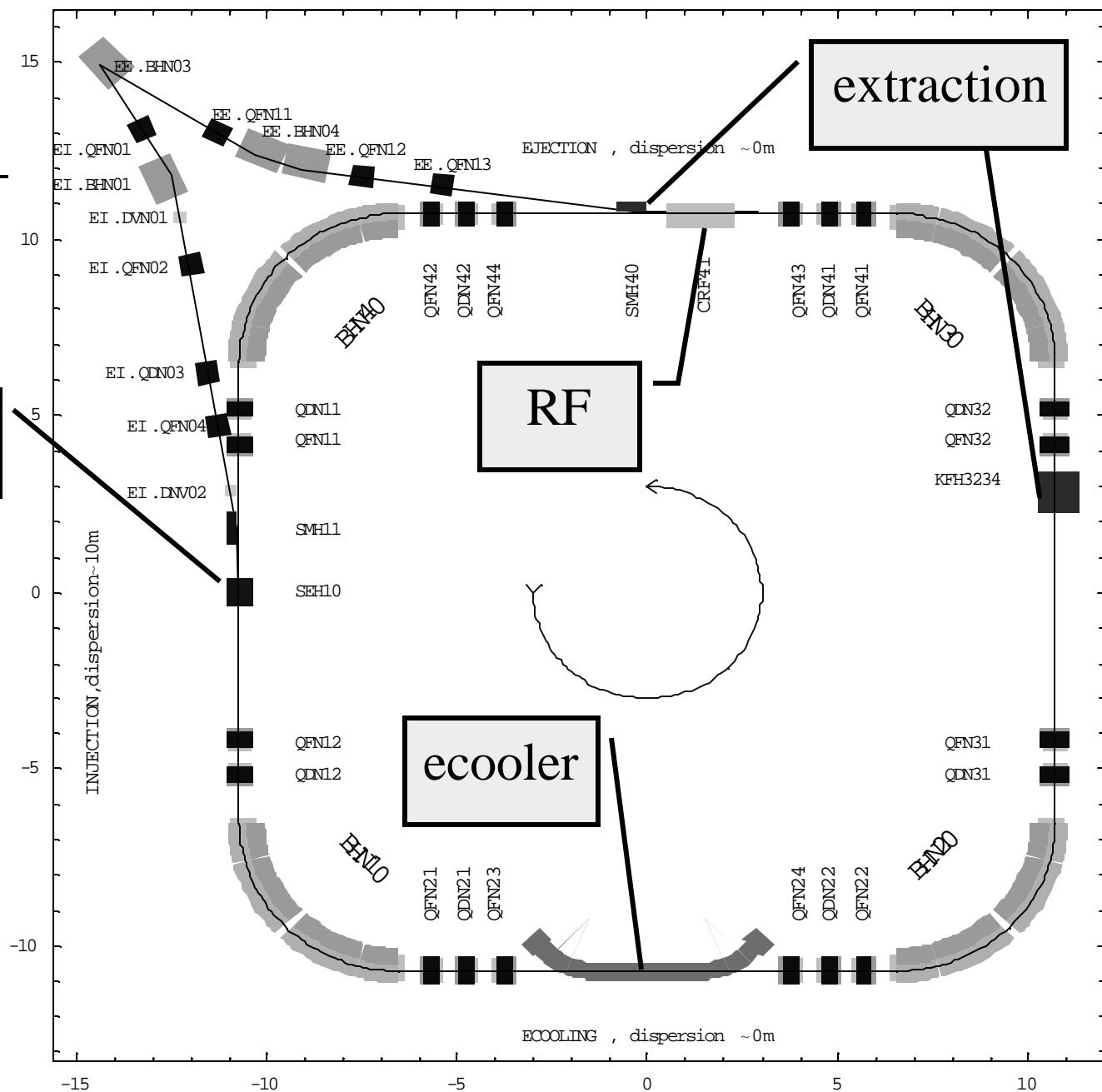
$\beta_h = 3m$,
 $\beta_v = 4m$



$\beta_h = \beta_v = 5m$, D=0

Ecooler,ejection

- still 2 periods , tune=(1.8,2.7) ,long. acceptance reduced to $\delta p/p \sim 1\%$
- 5 quad families, more flexibility.



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VACUUM



- During the tests in 1997, the static Lear vacuum was good ($\sim 5 \times 10^{-12}$ T without beam) but the lost lead ions (multiturn injection, e-ion recombination..lead 54^+ or res. gas charge exchange or..) degas the chamber walls.
- One lead ion releases $> 10^4$ molecules!!!!

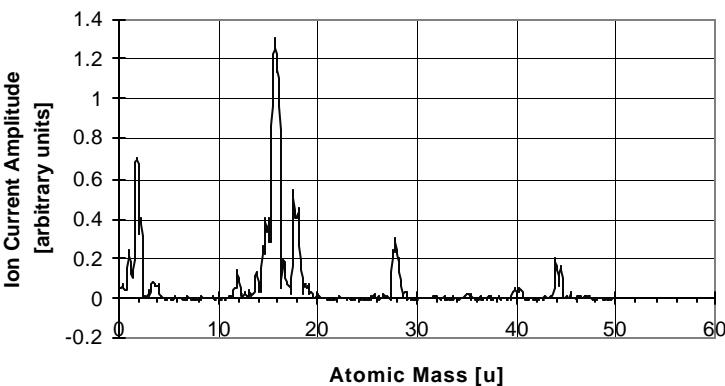


Measurement of the Vacuum Lifetime



- Vacuum quality measured with RGA.
- Lifetime due to the residual gas can be estimated from the spectra and agrees quite well with measurement.

Typical Mass Spectrum Obtained in Section 2.

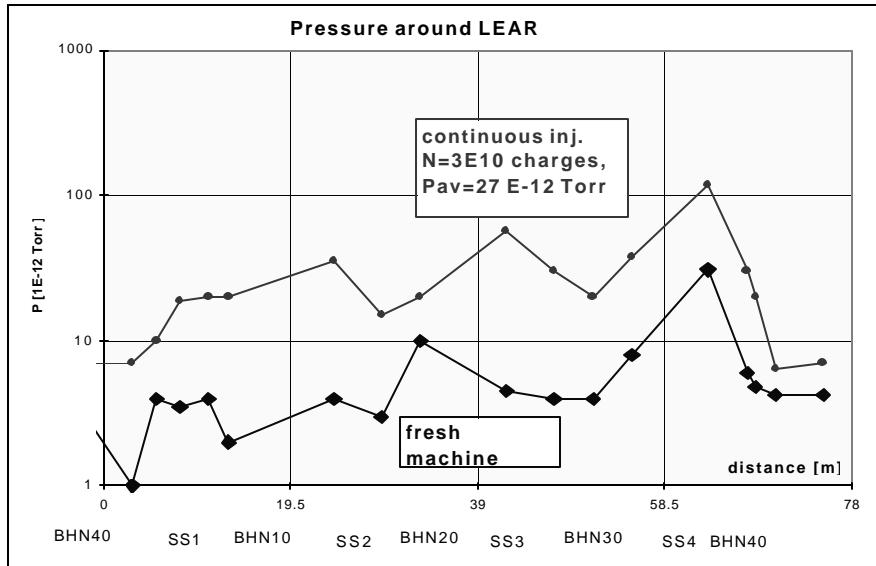


Measured mass spectrum

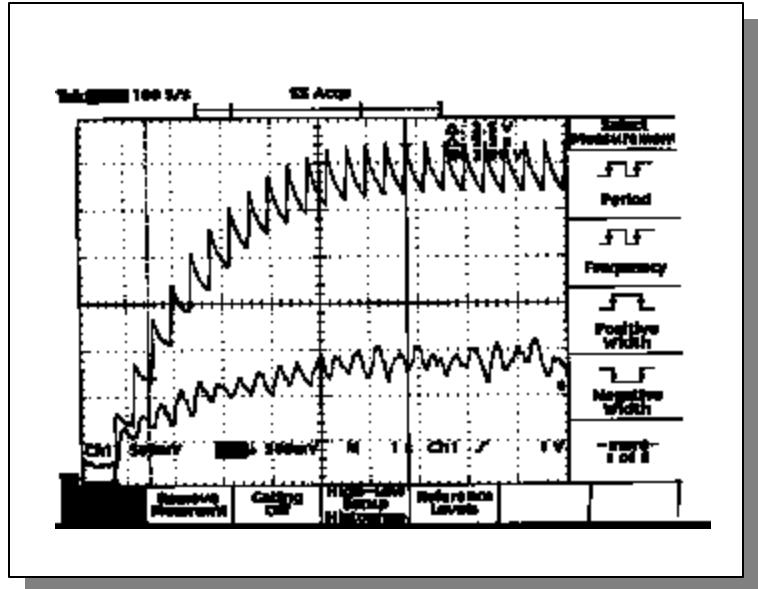
QMS mass spectrum						
time & date						
10:01 Apr. 30 1996						
Gas Species	Mass (u)	calibration factors	Peaks	Pi (N2 equ)	Pi (abs)	Percentage
H ₂	2	2.5	1.54	0.68	2.72218E-12	6.81E-12
He	4	2.27	3.13	0.07842	1.54796E-13	3.51E-13
	14			0.12109		
	15			0.5376		
CH ₄	16	0.78	0.71	1.27207	1.10689E-11	8.63E-12
H ₂ O	18	1	1	0.52279	3.22981E-12	3.23E-12
	28			0.28268		
CO	28	0.83	1	0.13202	8.15638E-13	6.77E-13
N ₂	28	1	1	0.15063	9.30751E-13	9.31E-13
O ₂	32	1.43	1	0.00889	5.49027E-14	7.85E-14
Ar	40	0.69	0.83	0.04275	3.18188E-13	2.2E-13
CO ₂	44	0.72	1.54	0.17569	7.04821E-13	5.07E-13
Kr		2.1	2.94		0	0
GAUGE PRESSURE =		2E-11		3.23726	2E-11	2.14E-11
						100

Gas composition analysis

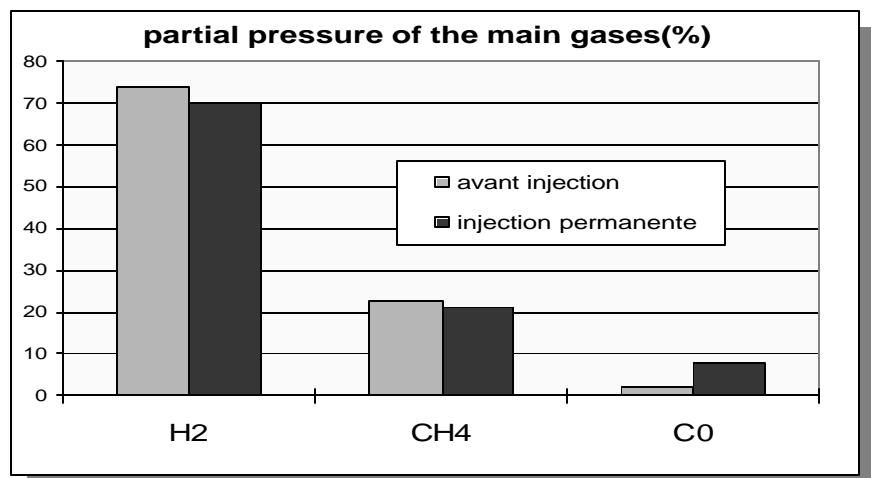
Effects on the Machine Vacuum



Recorded pressures around the machine



Evolution of the CO peak seen on a QMS during stacking



Partial pressures of main residual gas components

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VACUUM



- At end of linac3, tests of different vacuum chamber have been done which confirms the high outgassing rate and the desorption of CO, CO₂, CH₄ molecules.
- When ions are lost perpendicularly to walls, outgassing is decreased: then organise the losses on collimators made of a low outgassing material when possible.
- Beam scrubbing is effective
- More pumping speed
- The goal is to obtain an overall life time of 10-15 sec (30s due to vacuum only and 15-20s due to RR in ecool)



LEIR RF



	Q/A=0.25	Lead 54+	Q/A=0.5	
Energy d'injection	4.2	4.2	4.2	MeV/u
Momentum injection(p eq.)	353.691	353.691	176.845	MeV/c/Q
beta injection	0.095	0.095	0.095	
gamma injection	1.004	1.004	1.004	
Injection field	0.2827	0.2827	0.1414	T
Revolution frequency	3.61E+05	3.61E+05	3.61E+05	Hz
Bunching frequency(h=2)	7.22E+05	7.22E+05	7.22E+05	Hz
Ejection B _p	4.8	4.8	4.8	Tm
Ejection field min	1.1511	1.1511	1.1511	
Momentum(proton eq.)	1440	1440	1440	MeV/c/Q
Energy	67.145	72.2	245.824	MeV/u
β	0.3605	0.3725	0.6116	
γ	1.072	1.078	1.264	
Revolution frequency	1.377E+06	1.423E+06	2.336E+06	Hz
RF frequency(h=2)	2.754E+06	2.845E+06	4.672E+06	Hz

- 2 RF cavities using Finemet® giving 4kV each, built in collaboration with KEK
- Large swing in frequency but high impedance, Very short

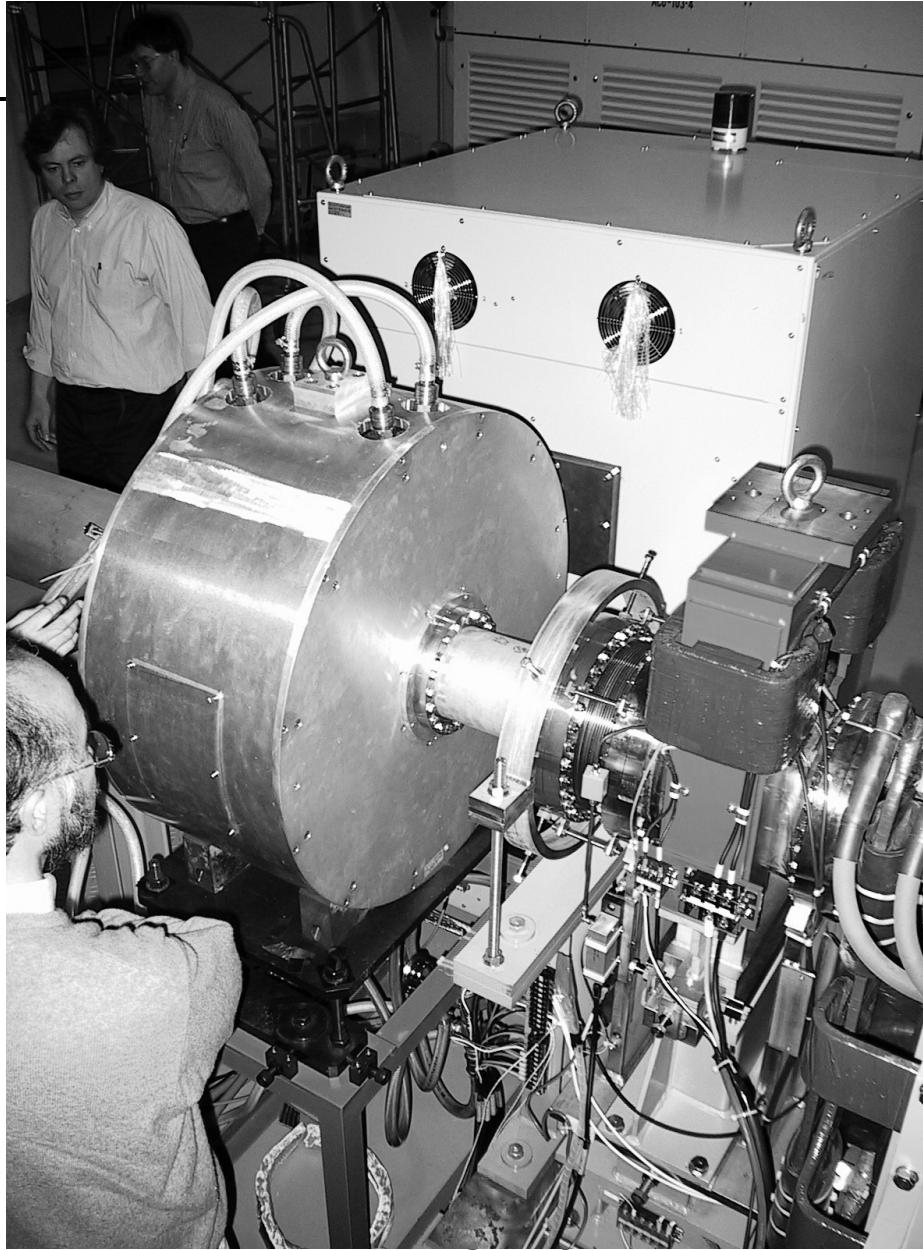


A nice cavity in HIMAC (Japan)



To the courtesy of
M. Paoluzzi

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CONCLUSIONS

- Project is now on its way
- The main problems have been understood, solutions proposed and are being applied.
- Commissioning of LEIR in 2005, PS/SPS in 2006/2007...LHC ions in 2008

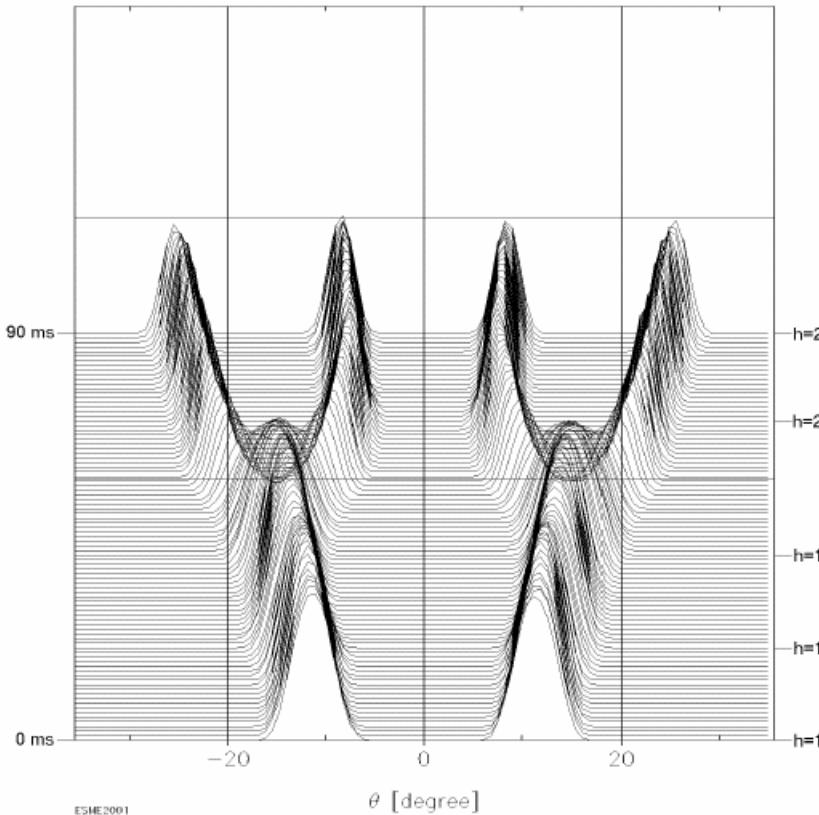


RF in PS



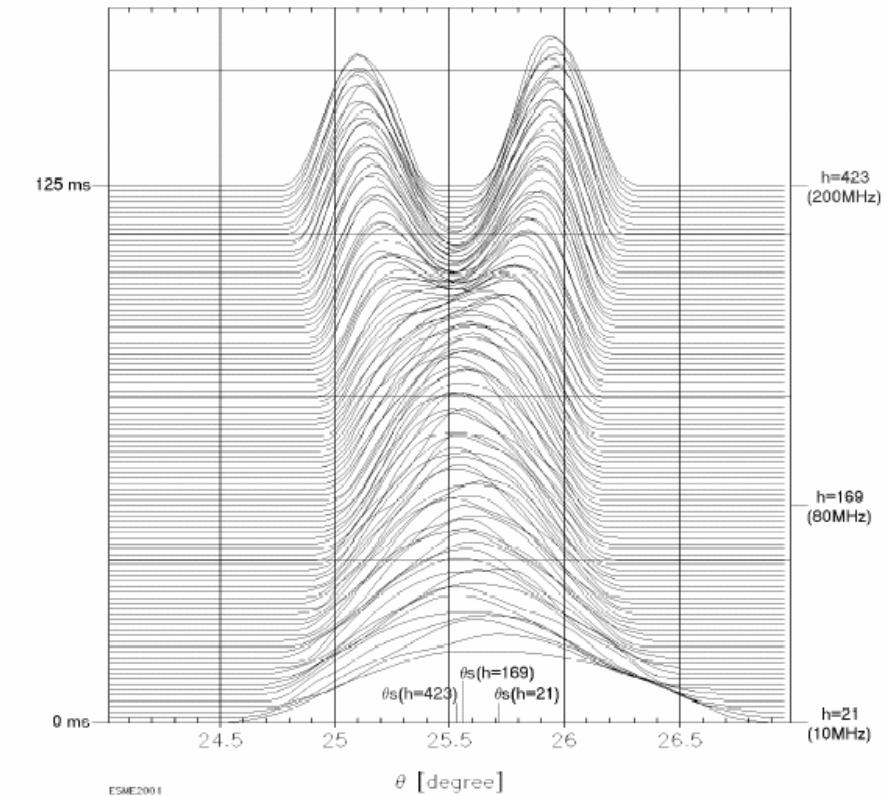
Batch Expansion and Bunch Splitting

Beam Current Profiles



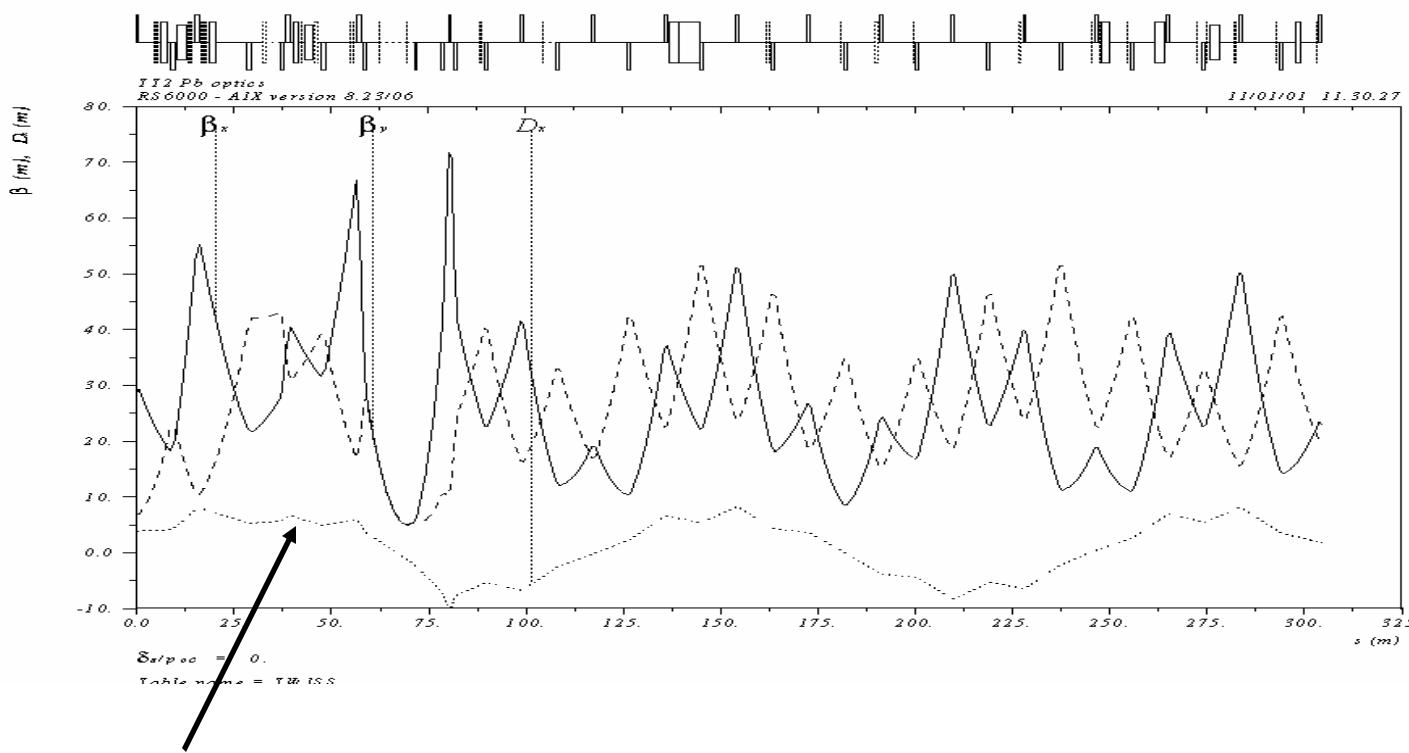
Rebucketing and Bunch Splitting

Beam Current Profiles





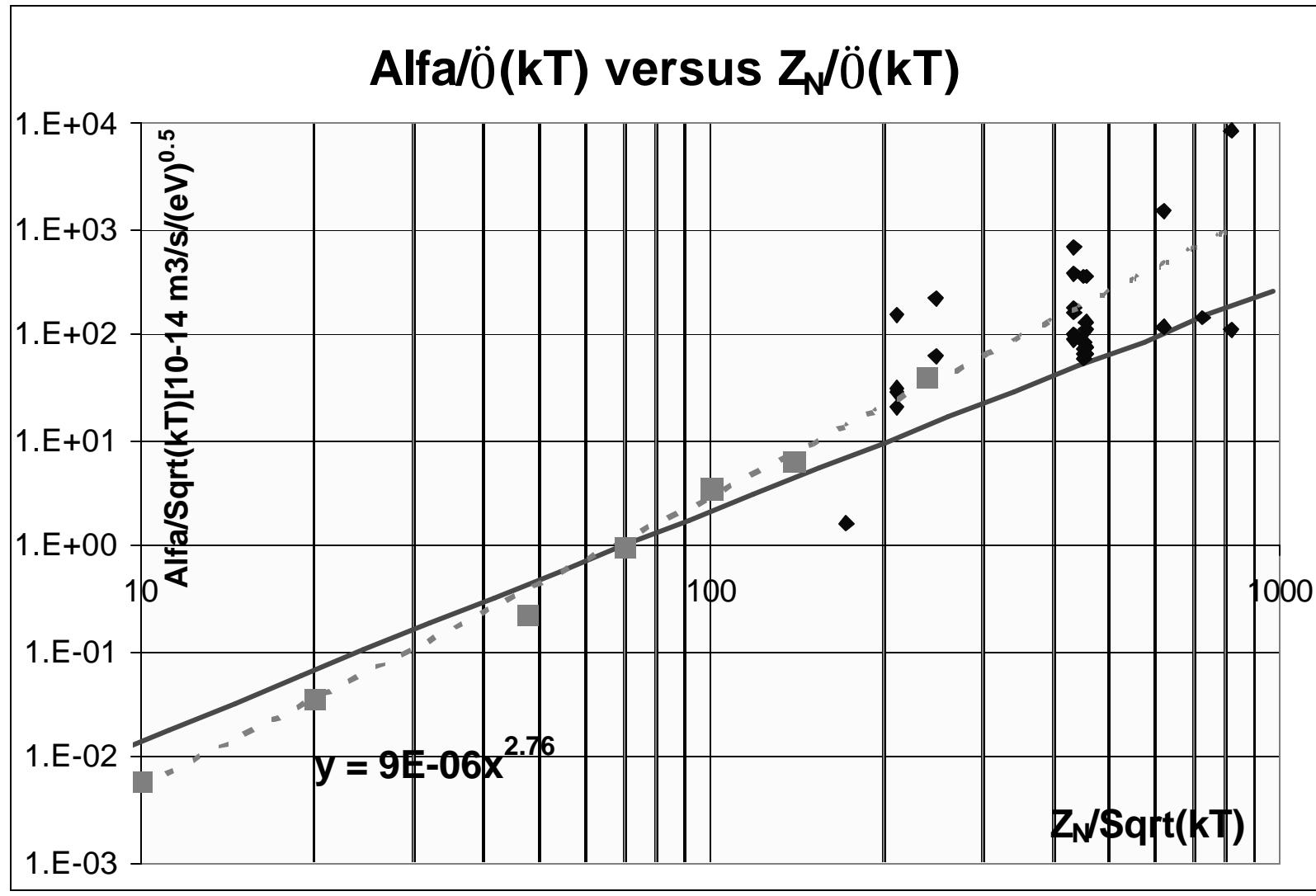
Transfer line to SPS(TT2)



- At stripper $\beta_{h,v} \sim 20m \rightarrow 5m$, $D \sim -1m$
- Blow-up reduced by a factor 4 compared to old(normal)optic....needs MD for SPS matching. $\Delta\epsilon \sim 0.2\mu m$ after re-matching in SPS?
- Need of 4 quads, 6 power supplies.(mostly recuperated)



Recombination e⁻-ions





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